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PATENT  
98095DIV4

#1218  
5/14/3

*Surles*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2815

Examiner: Richards

In re application of:

Gonzalez et al.

SEMICONDUCTOR RAISED  
SOURCE-DRAIN STRUCTURE

Serial No.: 10/008,653

Filed: November 9, 2001

AMENDMENT AND RESPONSE TO OFFICE ACTION

May 6, 2003

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Commissioner:

INTRODUCTORY COMMENTS

In response to the office action dated April 17, 2003 with respect to the above-identified application ("subject application"), please amend the claims of the subject application as follows:

Express Mail Number EU990151916US

Date of Deposit May 6, 2003

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to the Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450.

*John A. Detert*

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